



Form 1449 (Modified)

**Information Disclosure
Statement By Applicant**

(Use Several Sheets if Necessary)

Atty Docket No.
LMX-P026/P1068

Application No.:
10/672,085

Applicant:
Hao et al.

Filing Date
09/26/2003

Group
3722

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
MJ	1	Henderson, et al., "Cylinder Package effects on the purity of the electronic specialty gases" (June 1997) Unknown publisher, Vol 40, Iss. 6, 3 pp
	2	www.plastic-bottles-guide.com , "Blow Molding Techniques", (Sep 2003) 2 pp.
	3	www.dupont.com/teflon , "Techniques for Fabricating DuPont FEP Film – Heat Bonding", (Sep 2003) 2003 E.I. duPont de Nemours and Co., 4 pp.
	4	www.plasticsindustry.org/industry/process , "processing methods" (Sep 2003), 1999 The Society of the Plastics Industry, 4 pp.
	5	www.matweb.com , "AISI Type 316 Stainless Steel, annealed bar" (Sep 2003) 1996-2004 by Automation Creations, Inc., 3 pp.
	6	Entegris, "Teflon" Material Data Sheet", 2002 Entegris, Inc., 2 pp.
	7	www.gordonengland.co.uk , "Corrosion – The Corrosion Process" (Sep 2003) 9 pp.
	8	Saleem et al., "Ultrapure Materials – Gases: Examining the corrosion resistance of chromium-passivated stainless-steel tubes", (Sep 2003) 1997-2003 Canon Communications LLC, www.micromagazine.com/archive
	9	Collins et al., "Stainless Steel for Semiconductor Applications", (Oct 1997) 39 th Mech. Working & Steel Proc. Conference Proceedings of the Iron & Steel Soc., 1998, pp. 607-19
↓	10	Collins, "Stainless Steels for Semiconductor Gas Applications", (Jul/Aug 2002), Gases and Technology, pp. 10-15
MJ	11	www.mcnallyinstitute.com , "Corrosion problems associated with stainless steel 4-1", (Sep 2003)
Examiner /Marc Jimenez/ (10/31/2006)		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.